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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Toshio KODAMA et al. :
Appln. No. 10/525,311 : Art Unit - 2881
Filed: April 18, 2005 : Examiner - Kiet Tuan Nguyen
For: ION BEAM DEVICE AND ION :
BEAM PROCESSING METHOD : Docket No. S005-5460 (PCT)

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MS Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL RESPONSE

S I R:

In further response to the Office Action mailed October 5, 2006 and supplementing the previously filed response, applicants further amend their application as follows:

ADDITIONAL FEE:

No additional fee is believed required in connection with this response. However, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 8